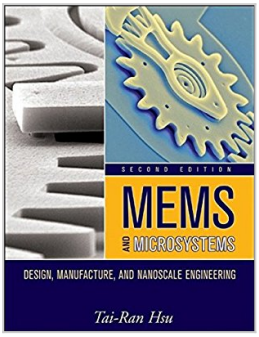

MEMS and Microsystems: Design, Manufacture, and Nanoscale Engineering

By Tai-Ran Hsu

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Editorial Review

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About the Author

Tai-Ran Hsu, PhD, is a Professor in the Department of Mechanical and Aerospace Engineering, San Jose State University, California. Dr. Hsu is the author of the earlier edition of this book, which is considered one of the bestselling textbooks on the subject of MEMS.

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